



JC10 Rec'd PCT/PTO 21 JUN 2005

PCT

00684.003651

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Ryo KURODA et al.)	Examiner: Unassigned
Application No.: 10/529,907)	Group Art Unit: Unassigned
Entry into U.S. National)	
Stage Under 35 U.S.C. 371: April 1, 2005)	
For: EXPOSURE METHOD AND APPARATUS,)	June 21, 2005
EXPOSURE MASK, AND DEVICE)	
MANUFACTURING METHOD)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed April 22, 2005, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the PCT publications, European patent document and Blaikie et al. article are also enclosed.

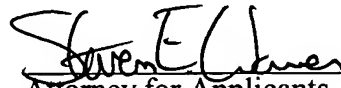
The cited documents were first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement. Specifically, these documents were cited in an International Search Report dated May 4, 2005, which was forwarded on June 3, 2005 (copies enclosed), from the European Patent Office in corresponding international patent application number PCT/JP2004/009283.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

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SEW/eab



FORM PTO 1449 (modified)		ATTY DOCKET NO. 00684.003651		APPLICATION NO. 10/529,907		
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT Ryo KURODA et al.				
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		FILING DATE April 1, 2005		GROUP Unassigned		
June 21, 2005						
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS SUBCLASS	FILING DATE IF APPROPRIATE
		US-5,973,316	10/26/1999	Ebbesen et al.	250 216	
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		WO 03/042748 A1	05/22/2003	PCT		
		WO 03/016781 A2	02/27/2003	PCT		
		WO 03/019245 A1	03/06/2003	PCT		
		EP 1 008 870 A1	06/14/2000	Europe		
						z
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Blaikie, R. J., et al. "Evanescent interferometric lithography," Applied Optics, Vol. 40, No. 10, April 1, 2001. Pp. 1692-1698.				
		International Search Report dated May 4, 2005, issued on June 3, 2005, in corresponding PCT patent application number PCT/JP2004/009283.				
EXAMINER			DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.